



Practitioner's Docket No. 14912.833

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Stephen E. Savas et al.)

Serial No.: 09/997,158) Group No.: 1763

Filed: November 28, 2001) Examiner: Luz L. Alejandro Mulero

For: Systems and Methods for Enhancing)
Plasma Processing of a Semiconductor)
Substrate)

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SEP 30 2003

TC 1700

MS Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Applicants submit this Amendment in response to the Office Action mailed on March 21, 2003. Reconsideration of the above referenced application is respectfully requested in view of the following amendments and remarks.

09/25/2003 ONGUYEN 00000019 232415 09997158
01 FC:1253 930.00 DA

09/25/2003 ONGUYEN 00000020 232415 09997158
01 FC:1202 36.00 DP